



Current Measurement and Associated Machine Protection in the ERL at BNL

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Outline



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Description of device

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Bunch structures

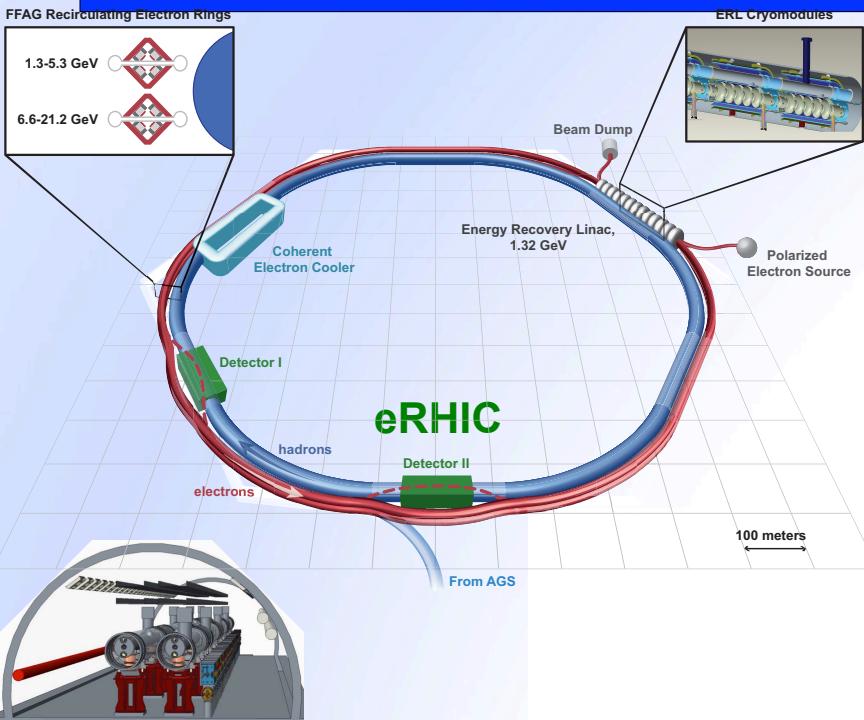
Summary



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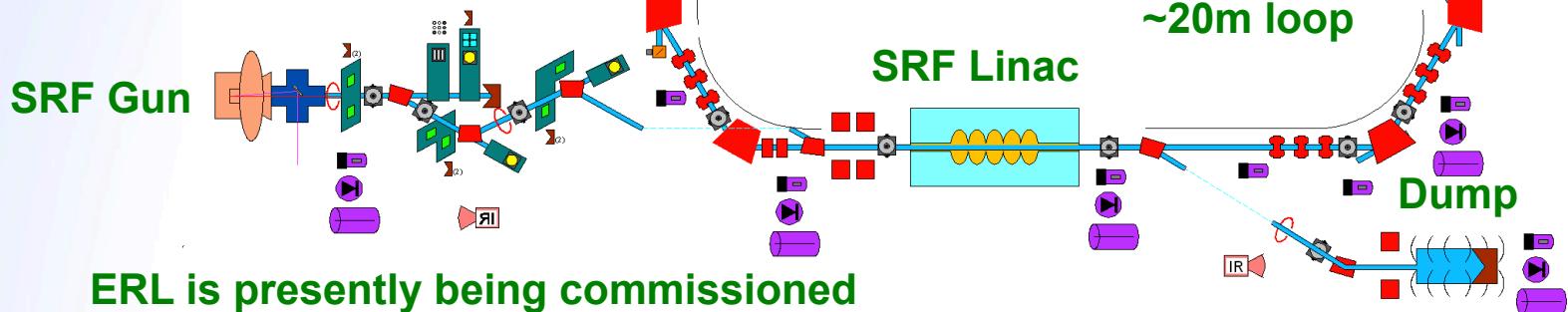


Introduction

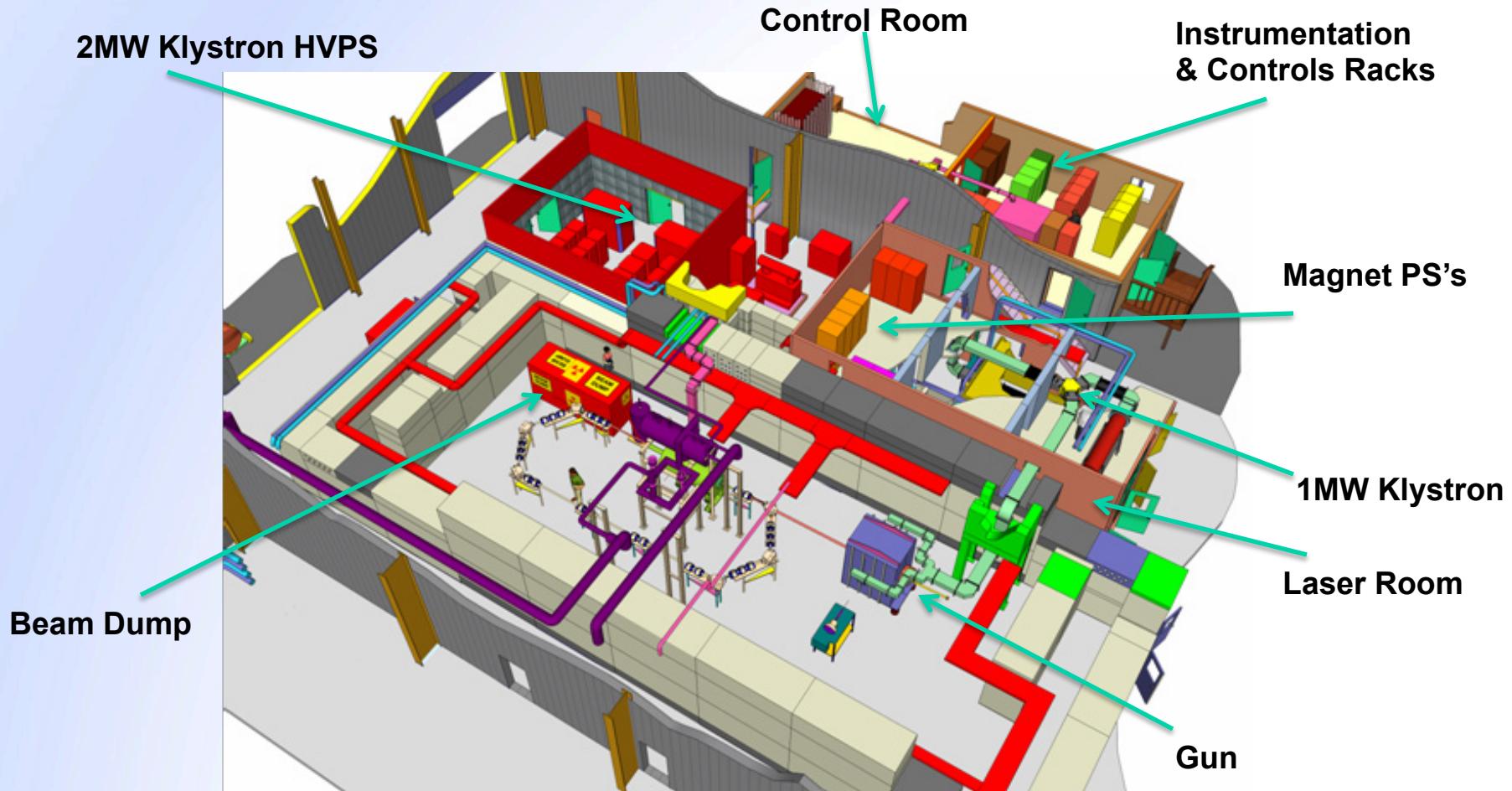


The R&D ERL facility serves a test bed for the Low Energy RHIC electron Cooling and eventually the electron-hadron collider, eRHIC (200GeV, 3.8km).

ERL Instrumentation Layout



ERL Facility Layout



ERL Early Commissioning Parameters



Parameter	High Charge Mode	High Current Mode	Comments
Beam Energy (Injection)		~2.5 MeV	
Beam Current	50 mA	500 mA	
Bunch Charge	0.05 – 5 nC	0.7 nC	
Bunch Rep. Rate	9.38 MHz	704 MHz	
Bunch Length	30ps	20ps	
Car Rep. Rate		5kHz	Limited by integrator recovery time
Car Length		0 – 7 μ s (ICT) up to CW (DCCT)	
Train Rep. Rate		1 Hz	
Train Length		0 – 990 ms	

ERL Instrumentation Requirements



Parameter	Expected Value / Range	Accuracy	Resolution	Comments
Current/Charge per bunch				
Current (Ops.)	50 μ A – 500 mA	1%	0.1% at I=500 mA	Lower range needed for tuning.
Bunch charge	0.05 – 5 nC, 1 Hz – 10 MHz	5%	0.1% (at 5 nC)	1% will be sufficient for ERL.

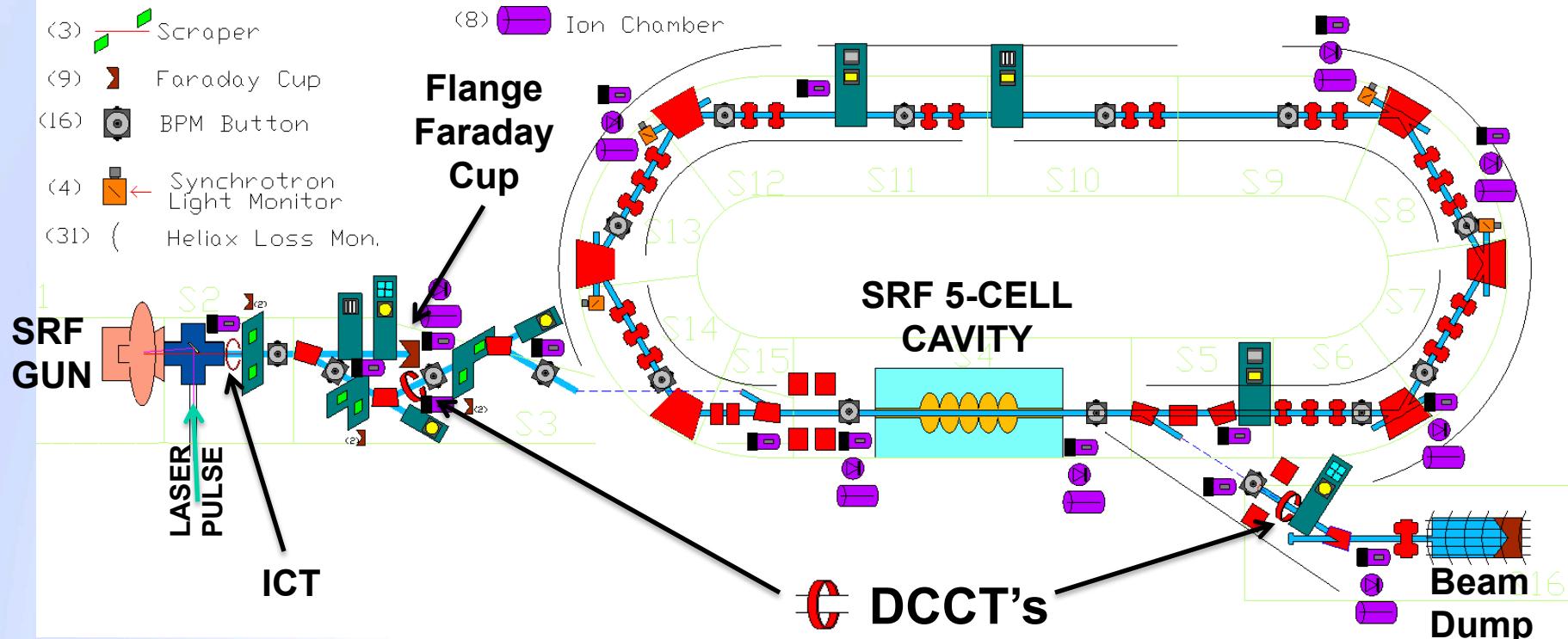
- TWO instruments cover the Measurement Extremes:
 - 50 pA – 500 mA (1 bunch up to CW)
 - ICT: **50pA – 800 μ A** ($1 \times 50\text{pC} – 50 \times 5\text{nC} / 200\mu\text{s}$)
 - macrobunches < 7 μs
 - DCCT: **50nA – 500mA** ($1000 \times 50\text{pC}$ pulsed – $C_{w_{max}}$)
 - macrobunches > 100 μs long in pulsed mode
 - **Blind to macrobunches between 7 – 100 μs !**
 - **Can't see beam in diag. beam line !**

Instrumentation Layout



- (2) □ DTR Screen
- (2) IR Infrared Camera
- (3) ■ HE YAG Screen
- (2) C DC Current Transformer
- (1) ■ Pepper Pot
- (1) ○ Integrating Current Transformer
- (1) ■ Emittance Slit
- (16) ■ PMT
- (3) ○ LE YAG Screen
- (8) ○ PIN Diode
- (3) ■ Scraper
- (8) ■ Ion Chamber
- (9) ■ Faraday Cup
- (16) ○ BPM Button
- (4) ■ Synchrotron Light Monitor
- (31) (Heliax Loss Mon.

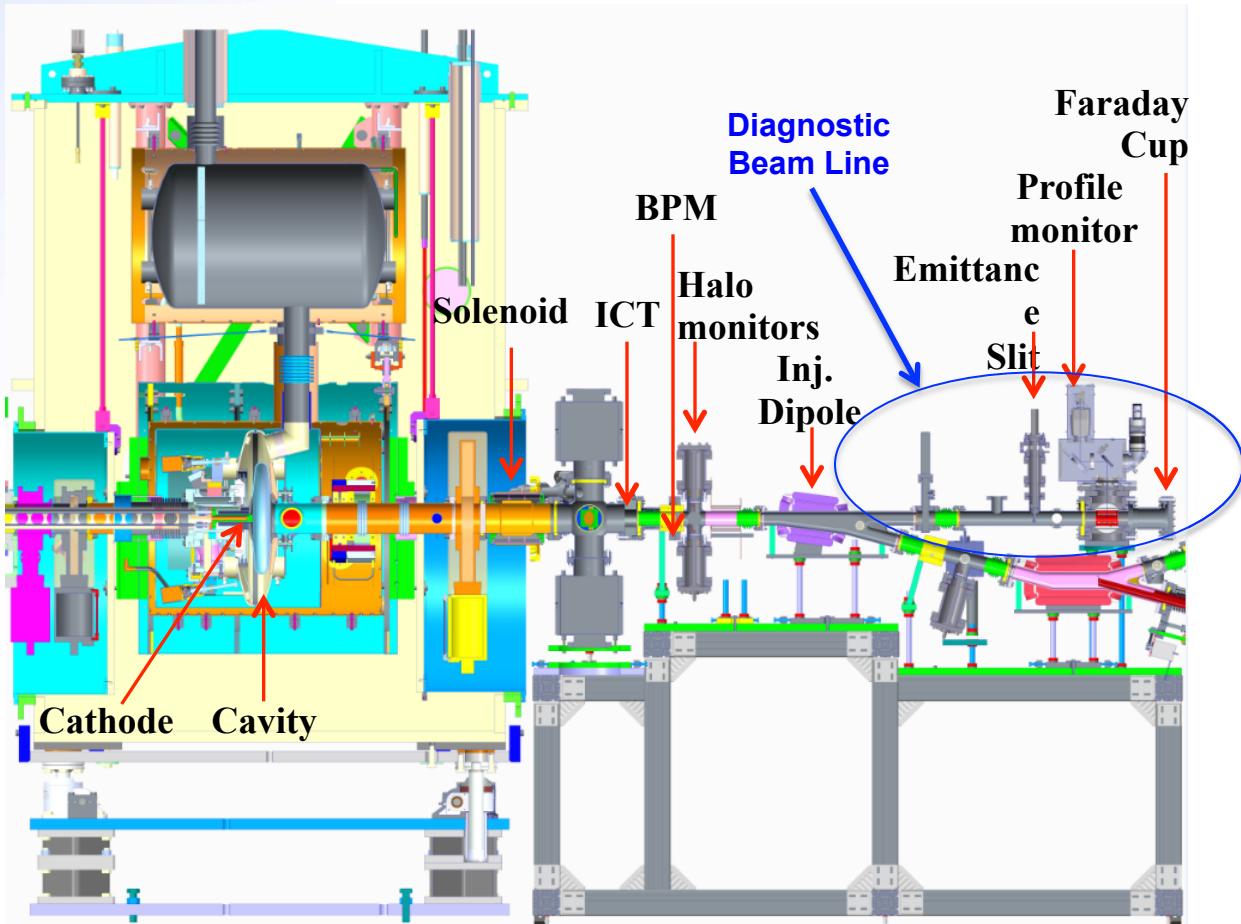
- Solenoid
- Quadrupole
- Dipole



Injection & Diagnostic Beam Line



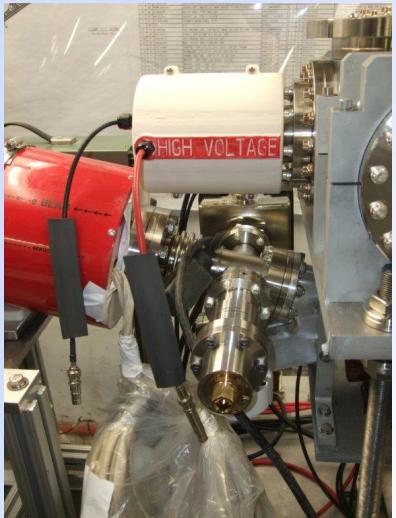
- ICT (5:1 turns ratio, $\sim 6\%/\mu\text{s}$ droop) + BCM-IHR electronics (10kHz)
- BPM
- Scraper
- Emittance Slit
- Profile Monitor
- Faraday Cup
 - SS flange on
ceramic break with
copper mesh noise
shield
- DCCTs (*not pictured*)
 - Zig-Zag & Extraction



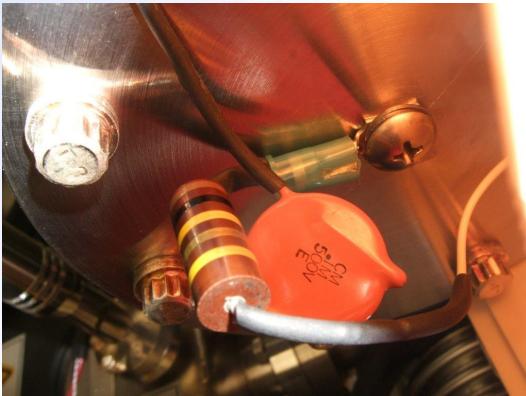
Faraday Cup



- Faraday Flange

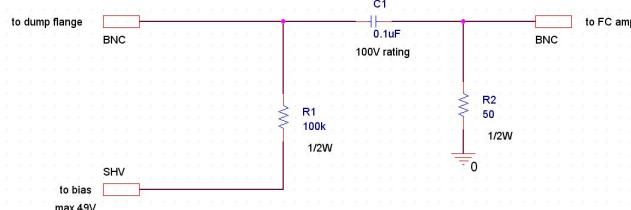


flange with enclosure to protect from exposure to faraday cup bias voltage

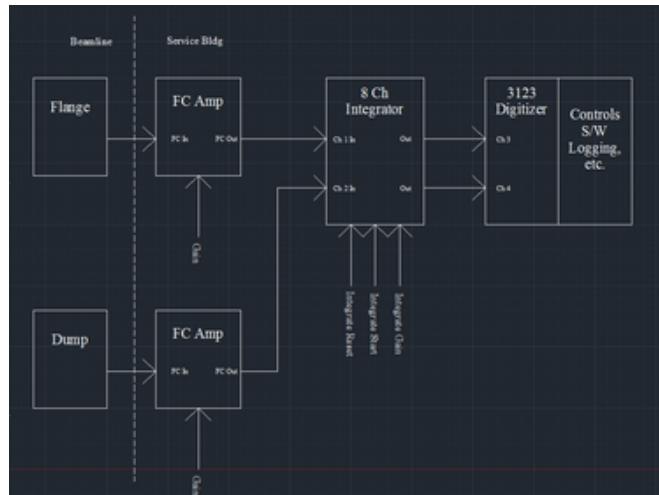


cap/resistor combo on Faraday cup/flange connection

1st beam tests made with O-Scope with direct connection...



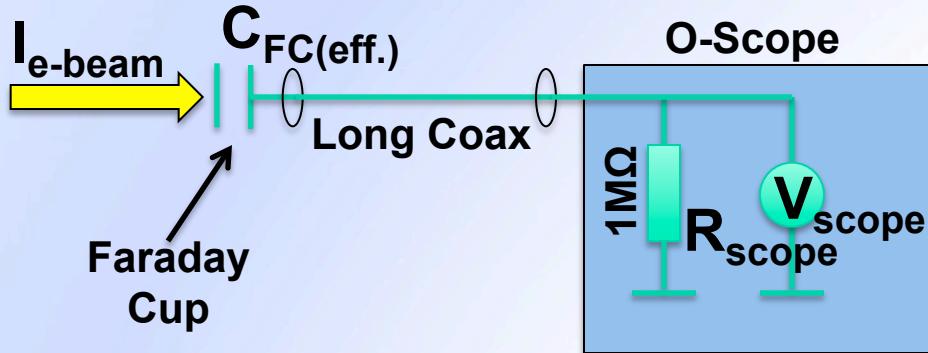
Circuit proposed for bias connection.



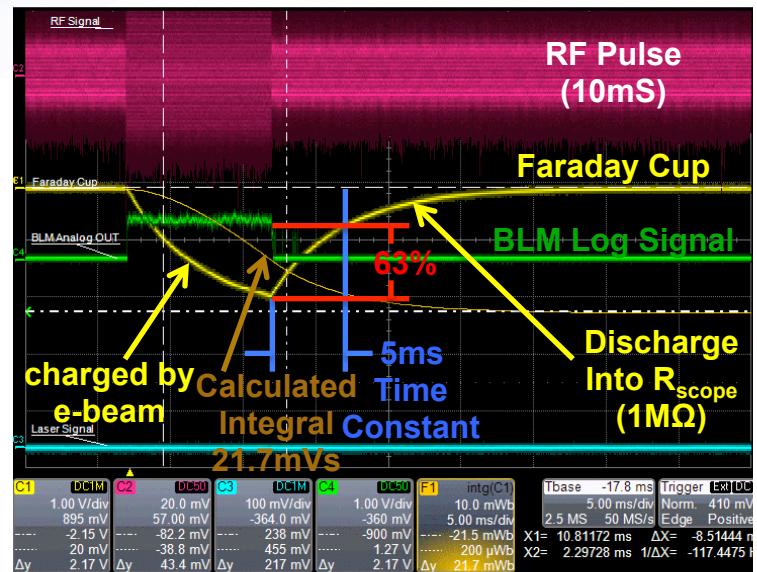
Amplifiers & integrators for two faraday cups (plus 6 halo monitors).



Diag. Beam Line Faraday Cup – DARK CURRENT



- Beam Current into Faraday Cup:
 - Finding effective C: $[\tau = RC]$
 - $C_{FC(\text{eff.})} = 5\text{ms} / 1\text{M}\Omega = 5\text{nF}$
 - We find a Dark Current $\approx 2\mu\text{A}$ during the RF pulse from the voltage measured on the effective capacitance of the Faraday Cup.



Dark Current

$$Q = \int I(t)dt = \frac{1}{R} \int V(t)dt$$

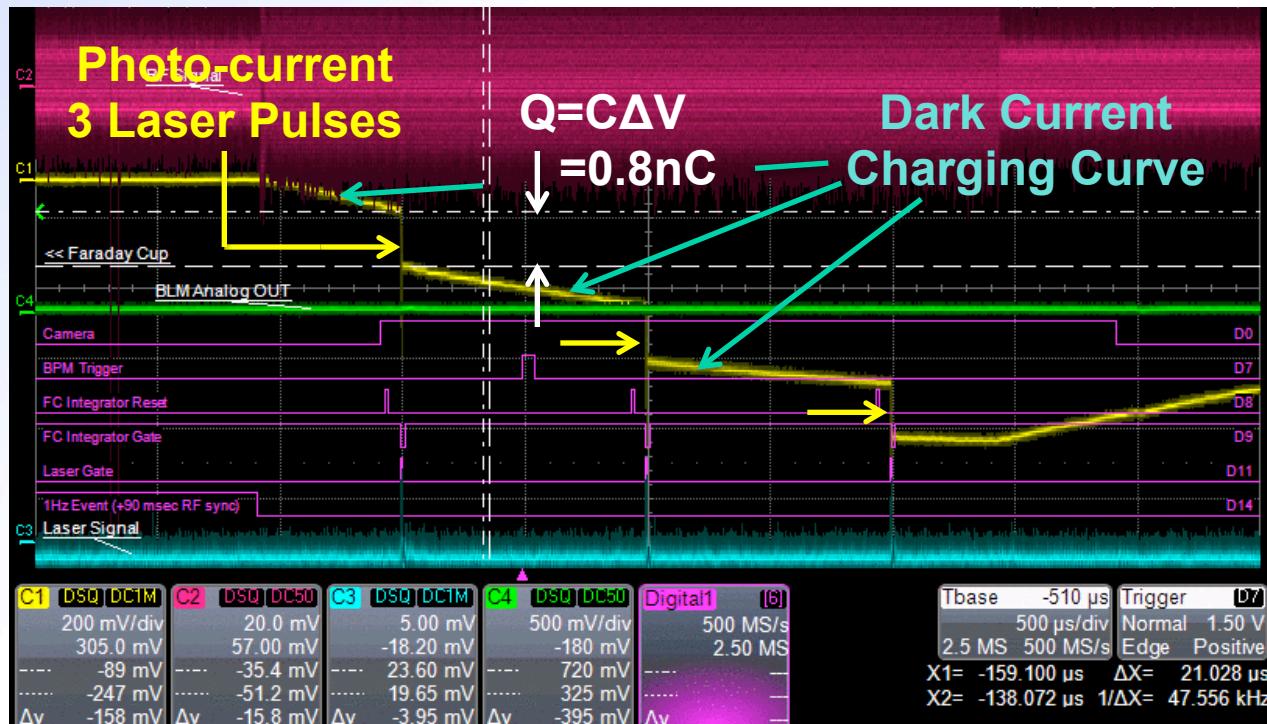
$$\bar{I} = \frac{Q}{T} = \frac{1}{RT} \int V(t)dt$$

$$I = 21.7\text{mVs}/1\text{M}\Omega/10\text{ms} = 2.17\mu\text{A}$$

Diag. B/L Faraday Cup – PHOTO-CURRENT



- ΔV for each beam current pulse gives the charge.
- $Q = C \Delta V$
 $= (5\text{nF})(158\text{mV})$
 $= 0.8\text{nC}$
- Superimposed on Dark Current curve



Integrating Current Transformer



Bergoz ICT-CF6-60.4-070-05:1-H-UHV-THERMOE

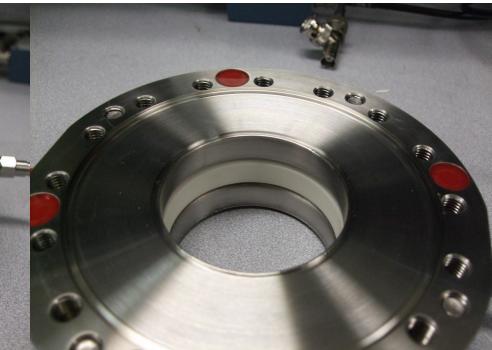
Integrating type, In-flange CT →

For bunches bunches & bunch trains

Bergoz IHR electronics

Noise <1pC beam charge

Calibrated



Mechanical details:

60.4mm ID

40mm axial length

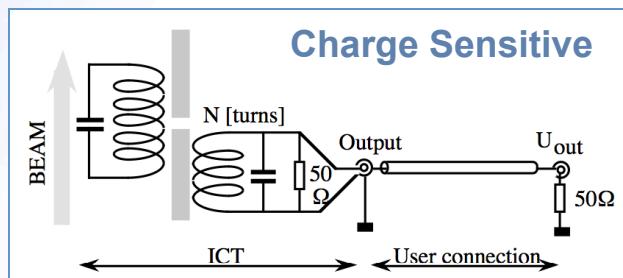
Rad-Hard option

Bakeable to 180C,

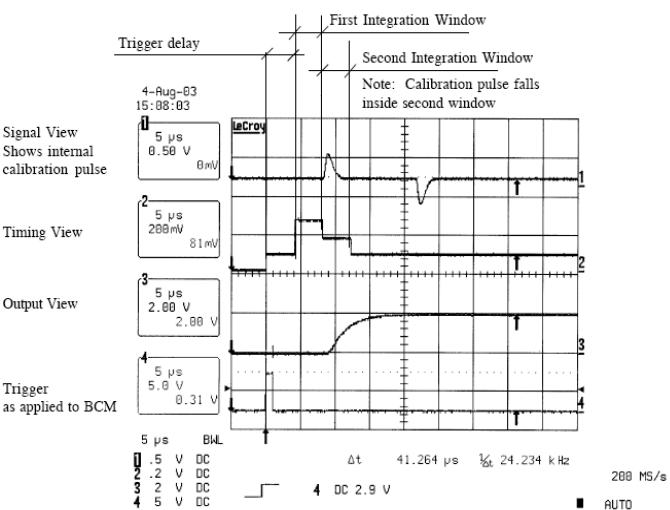
plan 48h at 150C

Separate bake-out zone

Internal TC, type-E



Signal processing timing diagram: Gate width <0.1us up to >7us



ERL requirements for bunch charge at 0.1-5nC:

5% accuracy

1% resolution (at 5nC)



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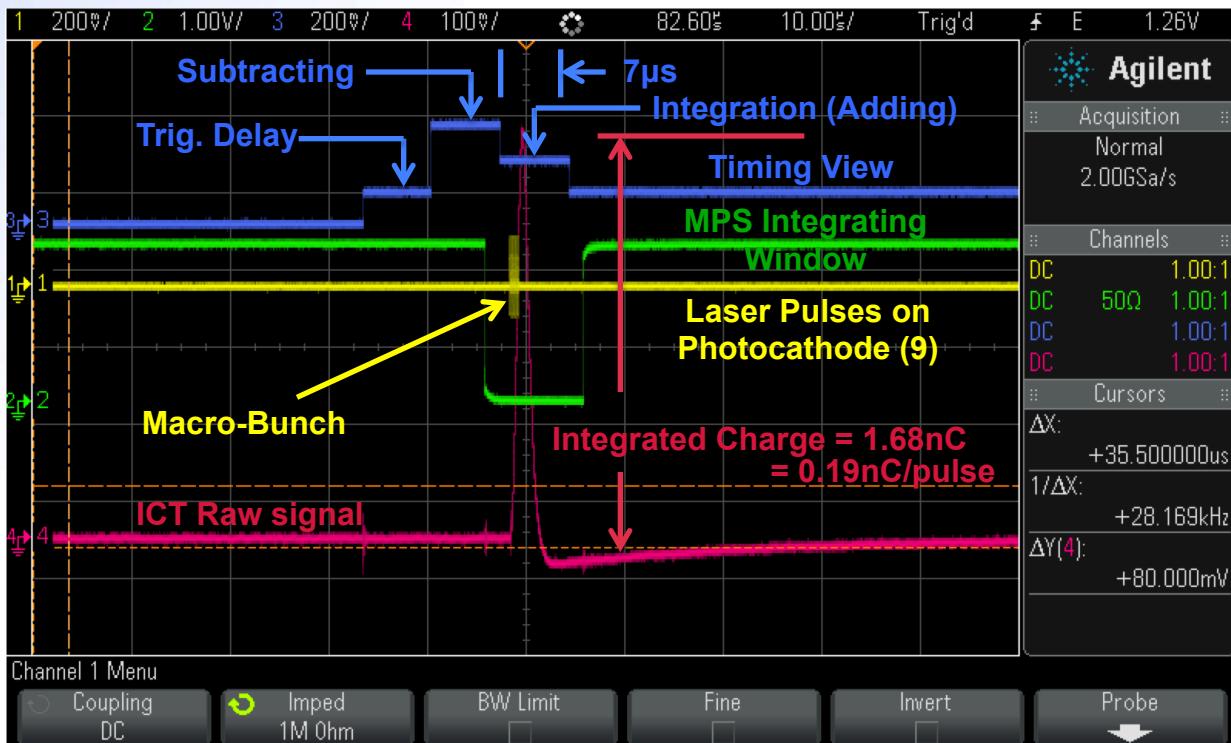


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Injection – Integrating Current Transformer



- 7 μ s Integration window
- 1 μ s macro bunch
- 9 pulses with 9.38MHz spacing and 44mW
- 1.68nC total charge
 - 0.19pC per bunch
 - (550pC_{max} demonstrated using 4W laser pulses)

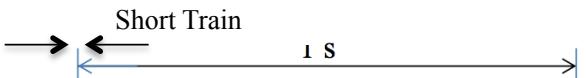




Bunch Patterns compatible with ICT

Bunch pattern for ramping up the beam current (for fault studies):

1 car with 1 bunch at 1 Hz



200pC/bunch

2 cars each with 1 bunch per car at 1 Hz



5kHz rep.

All cars contain 1 bunch over **full RF pulse**



I_{average}
(in train)

1 μA

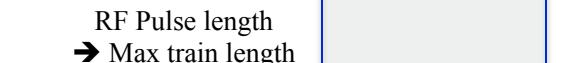
All cars each with 2 bunches over **full RF pulse** at 1 Hz rep.



2 μA

and so on until ...

50 bunches/car at 1 Hz rep.



RF Pulse length
→ Max train length

7 μs max



50 μA

1 – 50 bunches
per car

ICT

- Charge/car
- 7 μs max car length

Machine Protection – Over Current/Charge

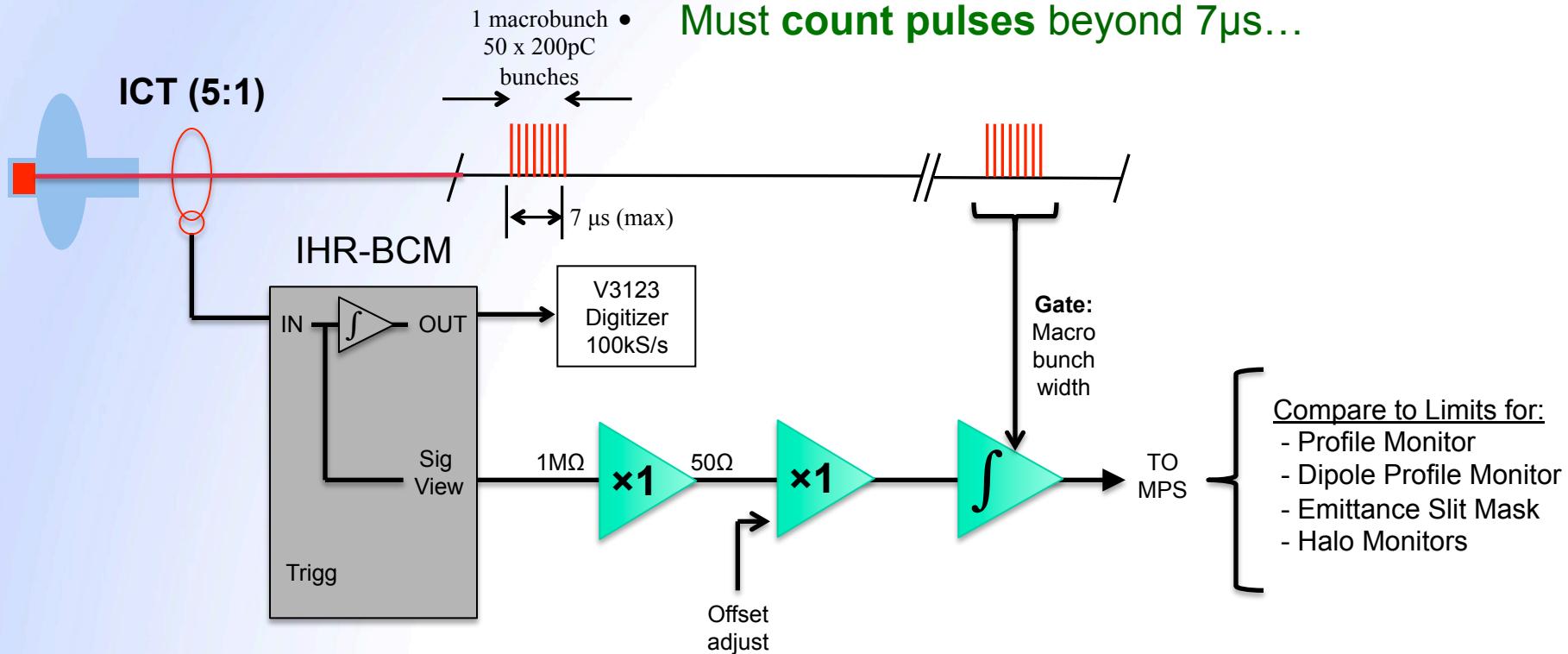


- The ICT is used (under limited pulse structures) to:
 - Limit operational current during commissioning & fault studies
 - Log operational current
 - Limit operational current in “Instrumentation Mode”
 - Specific **charge** thresholds are set during the insertion of each of the following instruments:
 - Profile Monitor
 - Dipole Profile Monitor
 - Emittance Slit Mask
 - Halo Monitors

ICT interface to MPS



- Dedicated amplifiers & integrators for ICT signal
- MPS compares Charge to limit for inserted device
- Limited to 7 μ s cars or macrobunches
- Must **count pulses** beyond 7 μ s...



Pulse Counting Scheme



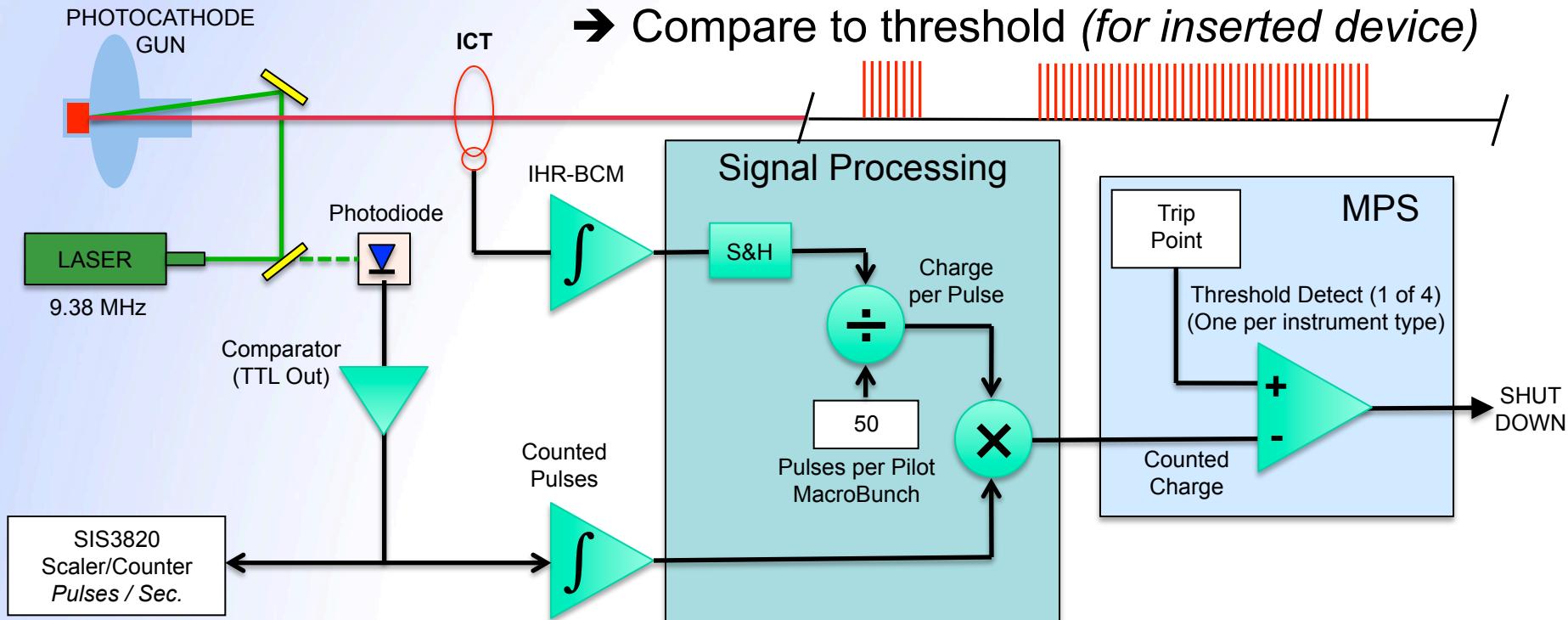
Extending **charge** measurement beyond ICT 7 μ s window

Pilot macrobunch charge measurement

÷ 50 pulses in pilot

× Counted laser pulses

→ Compare to threshold (*for inserted device*)



DCCT System



- High precision DC measurement
- DC – 10kHz bandwidth
- ~1uA resolution expected @ 1Hz

Modes:

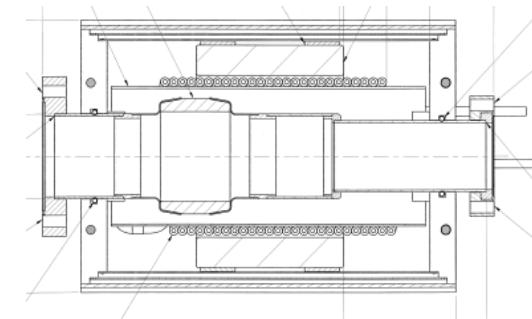
- Absolute Gun & Dump currents
- Differential Gun – Dump current for Machine Protection (10uA loss budget)

DIFFERENTIAL SCHEME:

The toroids installed in the injector and dump lines are connected via a current loop that threads both toroids and that is driven by a stable low-noise current source. The current of this source is regulated to minimize the output of the dump toroid. The output of the injector toroid is then the differential current measurement.



Bergoz NPCT system



BNL designed enclosure:

Calibration winding
Water cooling (80C max bake)
Mu-metal shield

Bergoz model # NPCT-S-115 New Parametric Current

Transformer, with options:

- 115mm ID
- Very high resolution ($<1\mu\text{A}/(\text{Hz})^{1/2}$)
- Radiation resistant sensor



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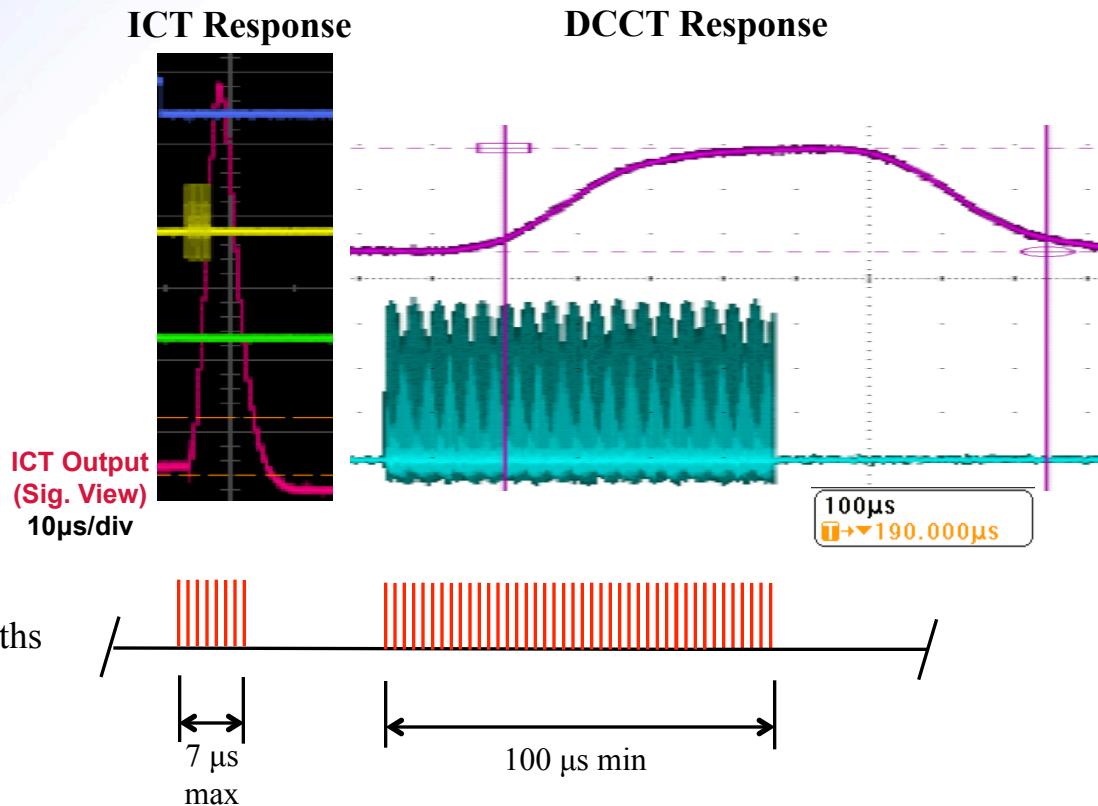
Time response of DCCT vs ICT



- DCCT requires long macrobunches ($>100\mu\text{s}$)

- Pulse structures tailored for each instrument
(*ICT vs. DCCT*)

- Instantaneous current measurement for each long macrobunch gives a “pulse current”

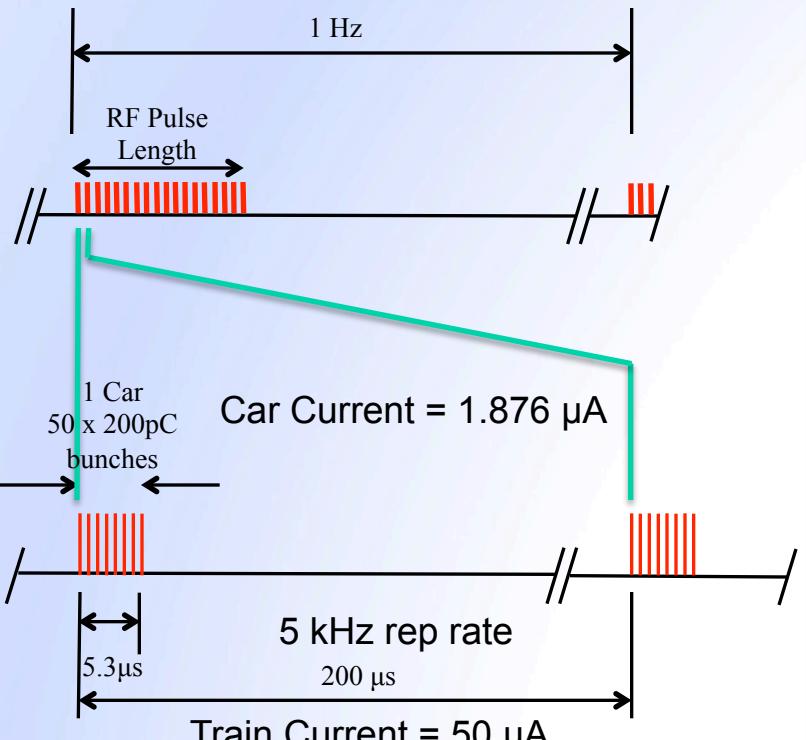


Bunch Patterns– ICT vs DCCT



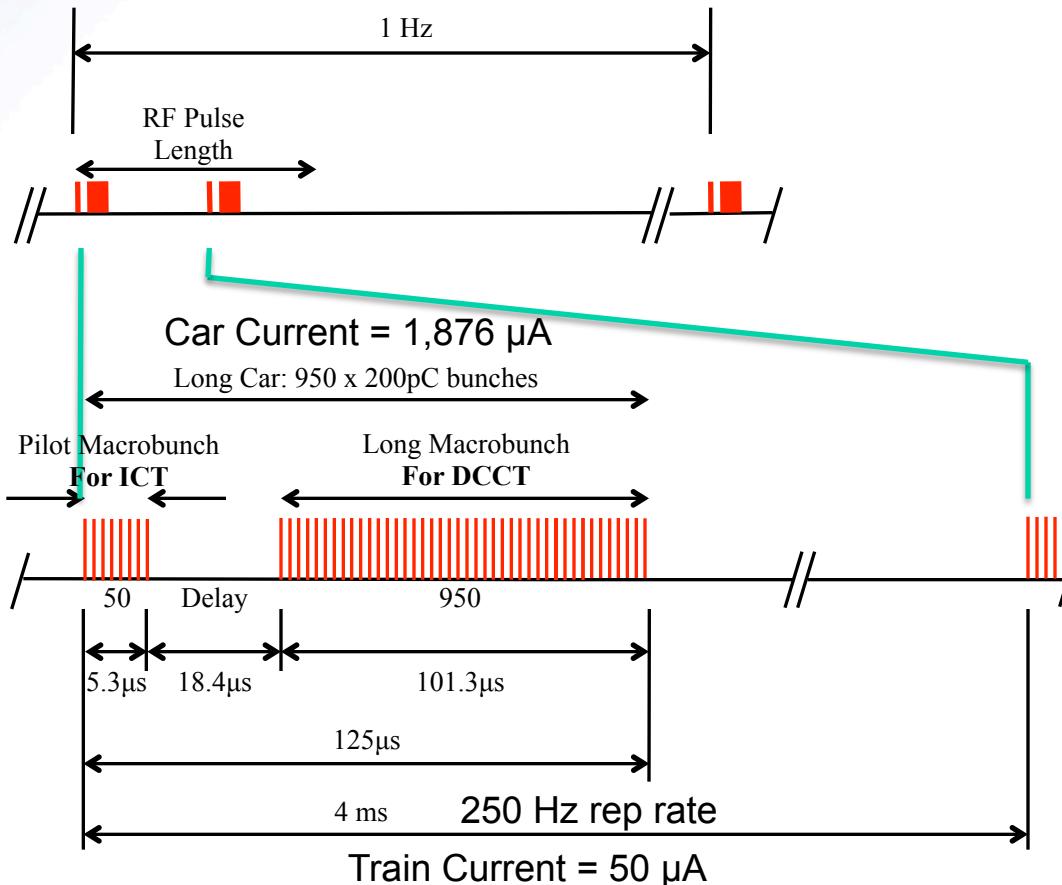
Pulse Structure for ICT

ICT is gated around the Car



Pulse Structure for ICT + DCCT

ICT is gated through the Pilot macro pulse
DCCT is sampled at the end of the Long macro pulse



Summary



- A Bergoz ICT is used to measure beam charge in short macrobunches
 - Up to $50\mu\text{A}$ average pulse train currents
- Measurements are confirmed with Faraday Cup
- A pulse counter is planned to be used to extend the measurement range of the ICT
- A Bergoz DCCT is used to measure long macrobunches
- Interlock thresholds are set in the Machine Protection System
- Future plans include the use of differential current measurements using separate DCCTs placed near injection and extraction.

Acknowledgments



BNL C-AD

R&D Energy Recovery Linac Group

Instrumentation Systems Group

Controls & Vacuum Group

Bergoz Instrumentation

Thank you for your attention!



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